

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

#313  
9-4-02

## **PRELIMINARY AMENDMENT**

BOX PATENT APPLICATION  
Commissioner for Patents  
Washington, D.C. 20231

Sir/Madam:

This Preliminary Amendment modifies the Continuation Application filed herewith.

Prior to examination of the Continuation Application, please amend as follows:

## **IN THE SPECIFICATION**

Following the Title, please insert the following paragraph:

This application is a Continuation of U.S. Patent Application Serial No. XX/XXX,XXX, entitled "SUBSTRATE AND METHOD OF FORMING SUBSTRATE FOR FLUID EJECTION DEVICE", having Attorney Docket No. 10010488-1, filed on January 31, 2002, assigned to the assignee of the present invention, and incorporated herein by reference. --

Please amend the Summary of the Invention as follows:

~~delete page 2, lines 6-15 (all inclusive) and insert the following:~~

-- One aspect of the present invention provides a method of forming an opening through a substrate. The method includes etching a first portion of the opening into the substrate from a first side, etching a plurality of second portions of the opening into the substrate from a second side opposite the first side, continued etching of at least one of the first portion and the plurality of